## Soft X-ray Photochemistry

Beamline: BL27SU

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Subgroups: Soft X-ray Photochemistry

Soft X-ray CVD

Atomic and Molecular Physics

Scientific Applications: High resolution molecular spectroscopy,

Photoionization dynamics by various correlation measurements,

Dynamics of inner-shell excited molecules,

Production and dynamics of novel core-excited states

by SR(UR)-laser double resonance techniques,

Site-specific dissociation processes of adsorbed molecules,

Growth of thin film of functional material,

Micro fabrication by functional material etching,

Clarification of the reaction mechanics for depositon and

process.

Source Characteristics: Figure-8 type linear undulator

 $\lambda u=100$ mm, N=44

Tunable range: 0.5~5keV

Peak brilliance:  $1.1 \times 10^{18}$  ph/s/mrad<sup>2</sup>/mm<sup>2</sup>/0.1% b.w.

at 500eV(*I*=100mA)

Total power: 2.7kW at 1st harmonic (500eV)

Power density: 1.7kW/mrad<sup>2</sup> at 1st harmonic (500eV)

X-rays at sample: Energy range: 0.5-2keV

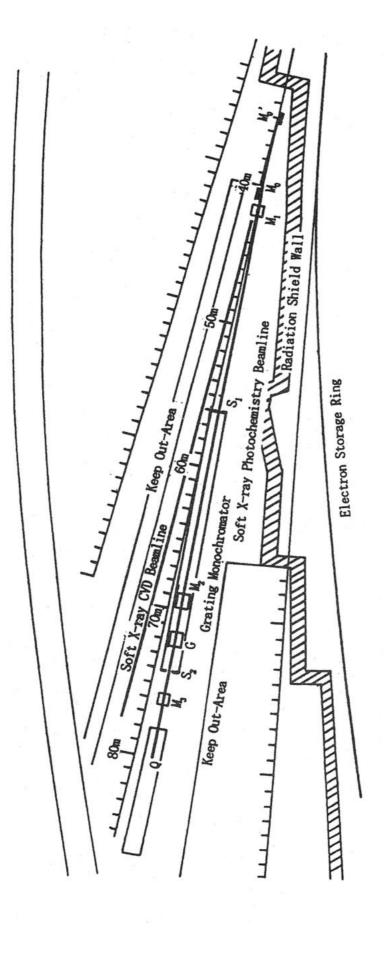
Linearly polarized

Energy resolution:  $\Delta E/E=10^{-4}$ Beam size:  $0.5 \times 0.5$ mm<sup>2</sup> Photon flux:  $10^{12}$  ph/s

microbeam capability of several-some tens µm diameter

in the energy range of 0.5-5keV

BL27SU: Soft X-ray Photochemistry



M<sub>o</sub> M<sub>o</sub>: Horizontally deflecting mirror, M<sub>1</sub>:Vertically focussing mirror Monochromator/S<sub>1</sub>:Entrance slit, S<sub>2</sub>:Exit slit, M<sub>2</sub>:Focussing mirror, G:Grating M<sub>3</sub>:refocussing mirror, Q:Sample position